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PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2335

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Tokuhisa OHIWA, et al. ) Group Art Unit: 2823  
)  
Serial No.: 09/604,724 ) Examiner: Maldonado, Julio J.  
)  
Filed: June 28, 2000 )  
)  
For: HIGH PRECISION PATTERN )  
FORMING METHOD OF )  
MANUFACTURING A )  
SEMICONDUCTOR DEVICE (AS )  
AMENDED) )

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

**AMENDMENT**

In reply to the Office Action dated January 28, 2002, with a period for response extending through April 29, 2002 (April 28<sup>th</sup> being a Sunday), please amend the application as follows:

**IN THE TITLE:**

On page 1, please replace the title at line 2 with the following title: HIGH PRECISION PATTERN FORMING METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE.

**IN THE CLAIMS:**

Please add new claims 21 – 23 as follows:

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04/30/2002 NMOHAMH1 00000017 09604724

01 FC:103  
02 FC:102

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